

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/709,420	<b>Applicant(s)/Patent under Reexamination</b> HAMIDIEH ET AL.
<b>Examiner</b> John E. Chapman	<b>Art Unit</b> 2856	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner